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IPW

Applicants: K. NAGATA et al.  
Serial No.: 10/613,148  
Filed: July 7, 2003  
Title: EXPOSURE APPARATUS AND EXPOSURE METHOD  
Group: 2125  
Examiner: JARRETT, Ryan A.  
Confirmation No.: 6729

**AMENDMENT**

Mail Stop: AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

November 15, 2005

Sir:

In response to the Office Action dated October 18, 2005, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the claims begin on page 2;

Remarks are included beginning on page 8; and

Authorization begins on page 10.